

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)	
Vyvoda et al.	)	
Serial No.:	)	Examiner: Toledo, Fernando L.
09/918,853	)	
Filed:	)	Group Art Unit: 2895
July 30, 2001	)	
For:	)	
Process for Fabricating a Dielectric	)	
Film Using Plasma Oxidation	)	

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Please enter the following amendment and remarks in response to the PTO

Communication mailed March 24, 2010.